

EASITRAIN

ESR6 Project description

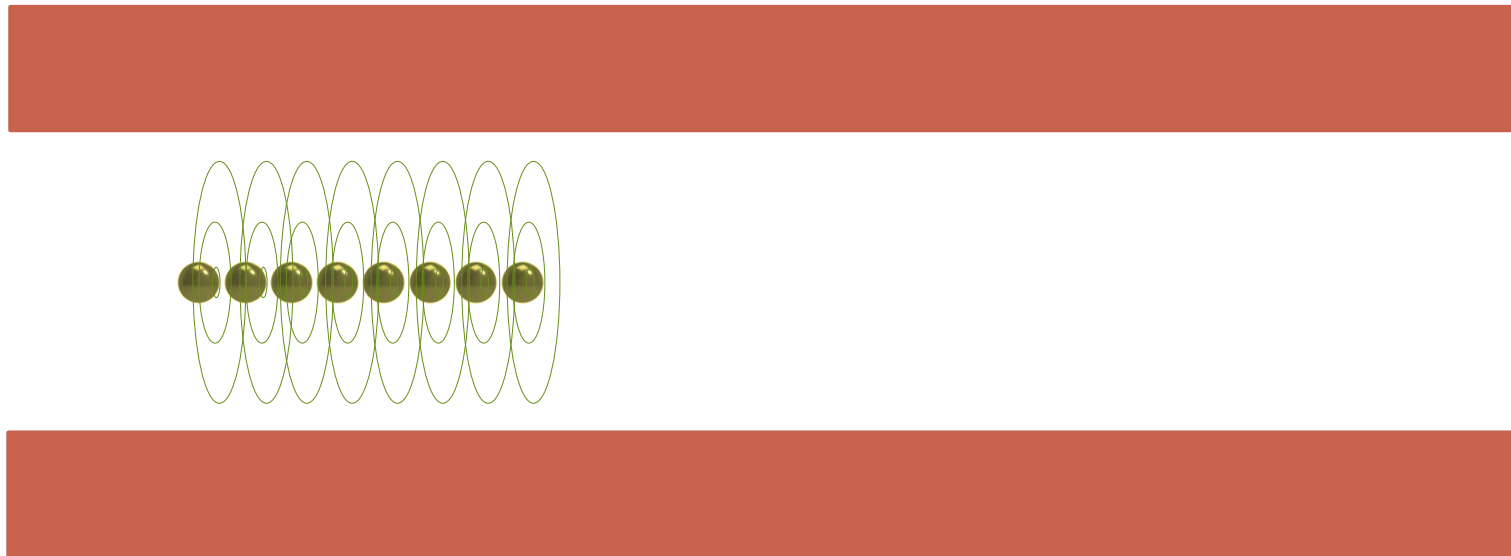
Aisha Saba

(Emilio Bellingeri)

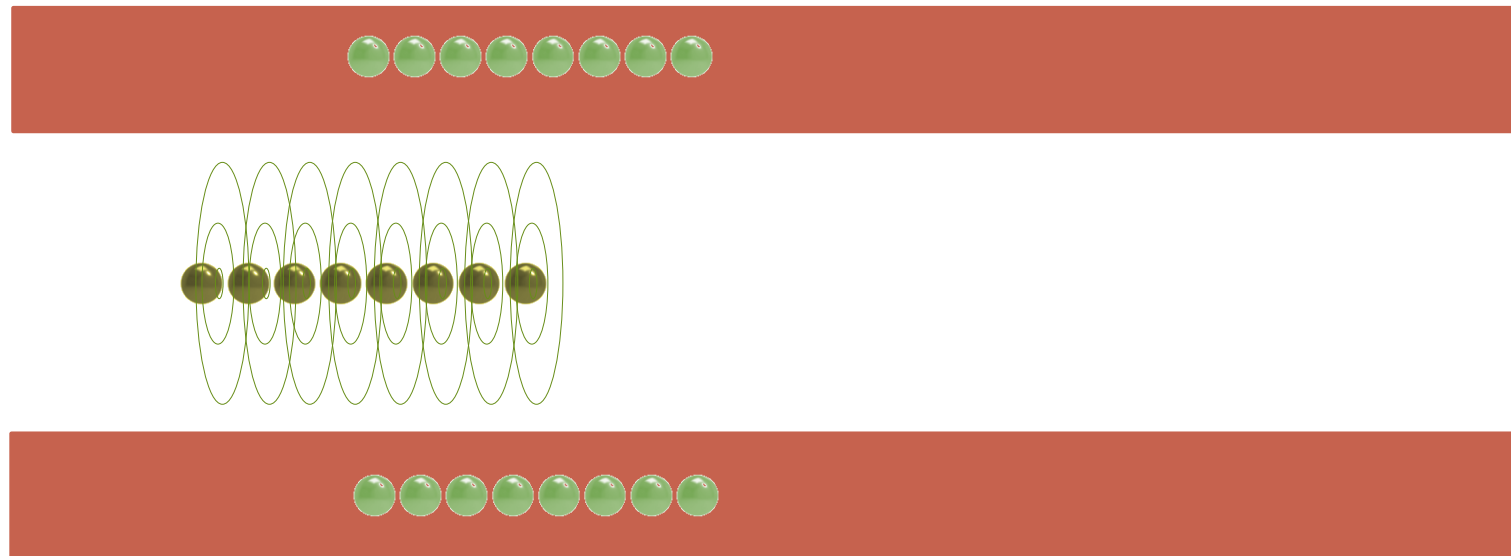
10^{11} protons will circulate in bunches in the ring at $v \approx c$



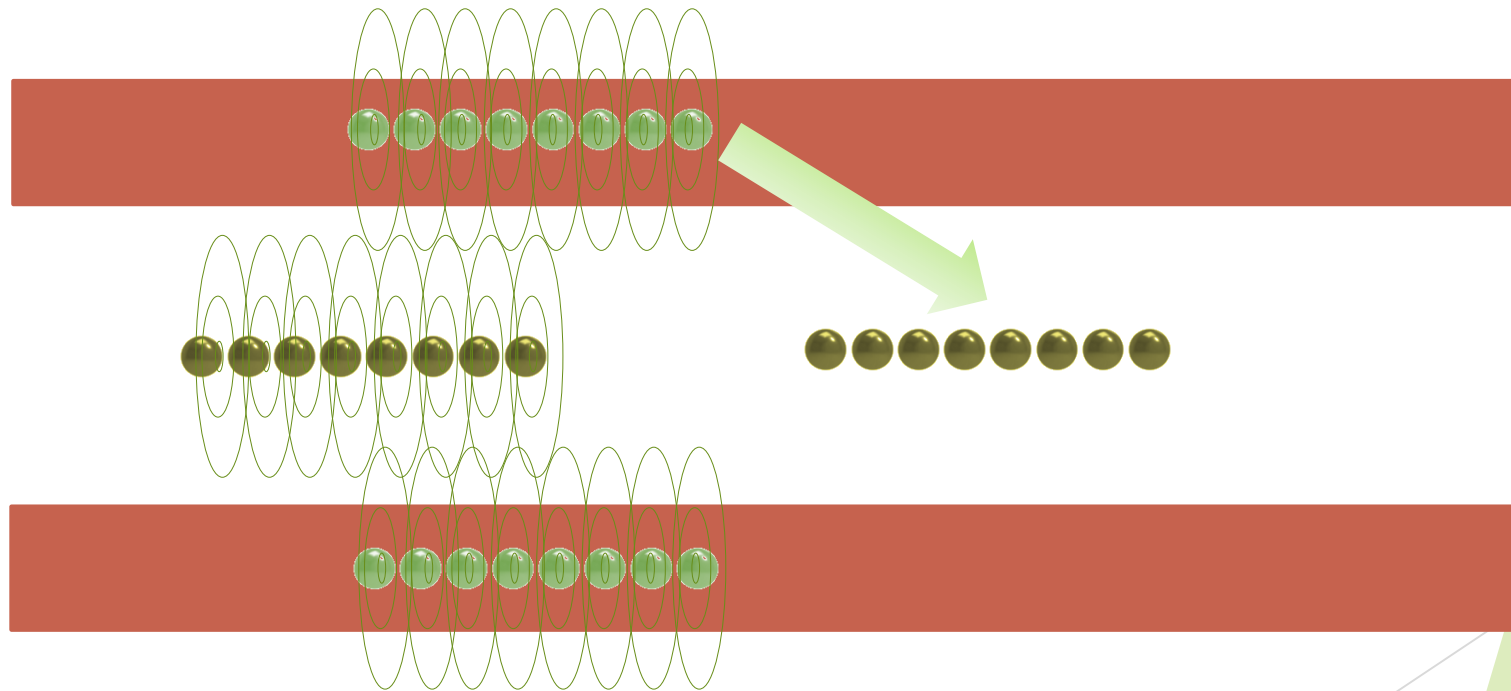
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The EM Field will produce an image current in the screen
The image current will dissipate
Due to the delay, it will affect back the beam causing instabilities.



The surface resistance of copper at 50 K may not be sufficiently low to guarantee a safe operational margin for the FCC-hh beams, in particular at injection energy.



Introduction of a HTSC coatings to mitigate the beam impedance



HTS films requirements for beam screen

Material under extreme condition !

$T=50\text{ K}$ Very high operation temperature (for a superconductor)



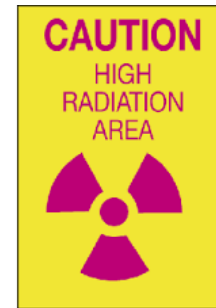
$B=16\text{ T}$ Very High magnetic field



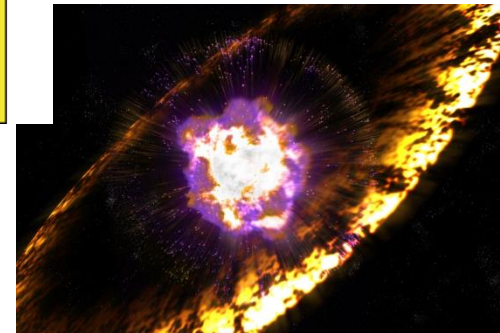
$\nu=1\text{GHz}$ Very high frequency



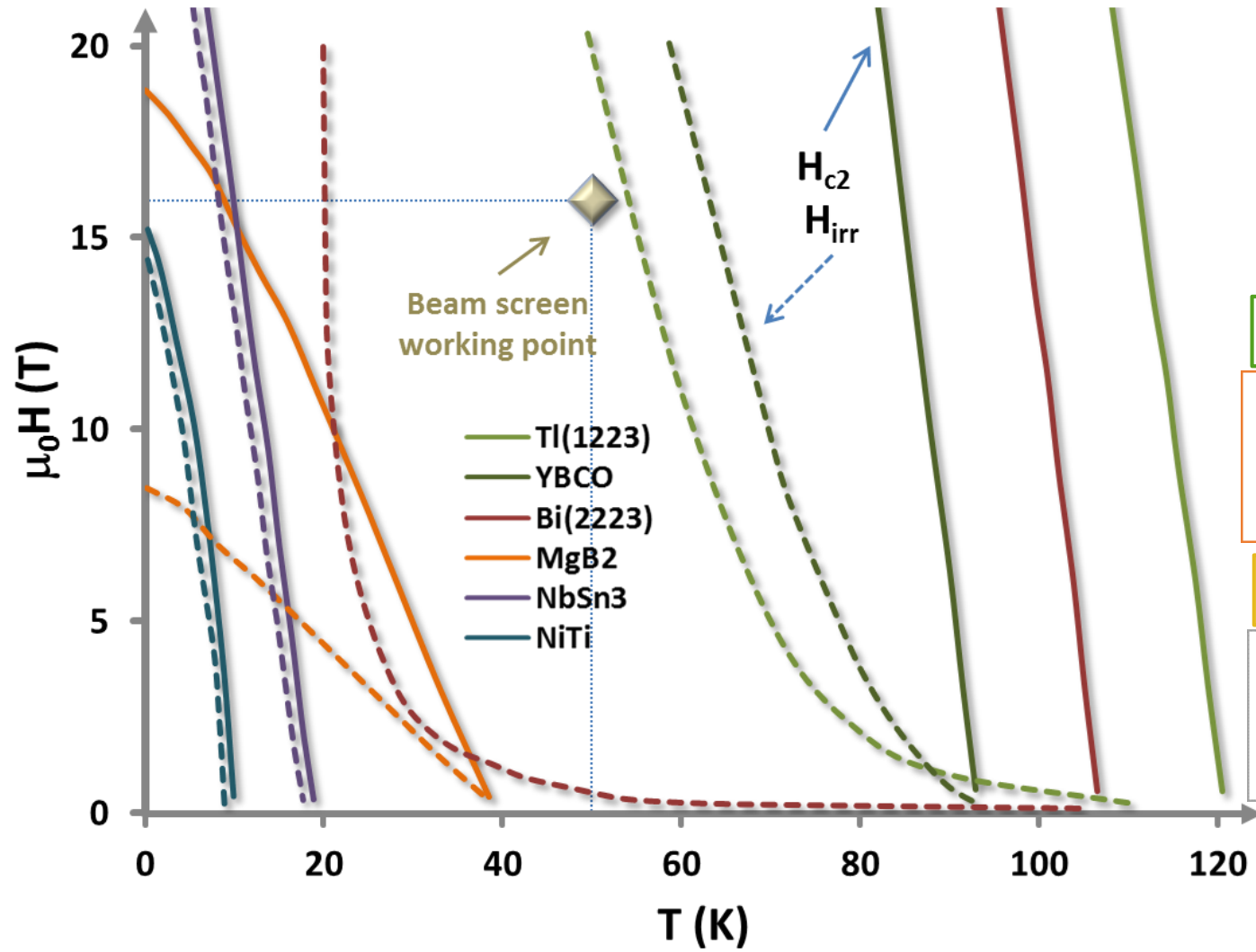
High synchrotron radiation intensity



Boundary materials with 100 TeV particles
(only supernova burst can exceed this energy)



Superconducting materials phase diagram



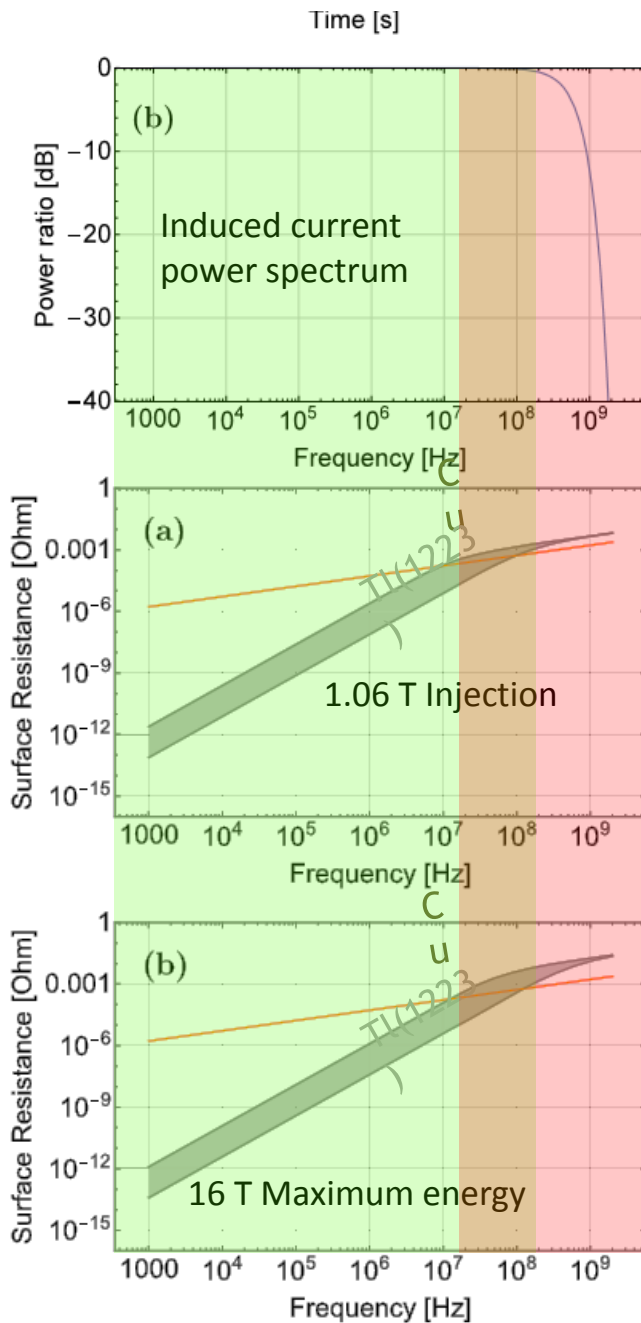
$$R_{fl} \approx \sqrt{\frac{B}{B_{c2}}}$$

YBC

$$\frac{H}{H_{c2}} = \sqrt{\frac{16 T}{80 T}} = 0.45$$

Tl

$$\frac{H}{H_{c2}} = \sqrt{\frac{16 T}{140 T}} = 0.33$$



TI(1223) estimated surface resistance

$$\nu_0(B_0) = \frac{\rho_n \sqrt{B_0} J_c(B_0)}{\sqrt{\Phi_0} B_{c2}} \quad \text{Depinning frequency}$$

$$Z_{sf} \equiv Z_f = Z_n \sqrt{\frac{B_0}{B_{c2}}} \quad \text{for } \nu \gg \nu_0,$$

$$R_{sf} \equiv R_f = \frac{R_n}{\sqrt{2}} \sqrt{\frac{B_0}{B_{c2}}} \left(\frac{\nu}{\nu_0} \right)^{3/2}, \quad R_n = \sqrt{\mu_0 \rho_n \pi \nu}$$

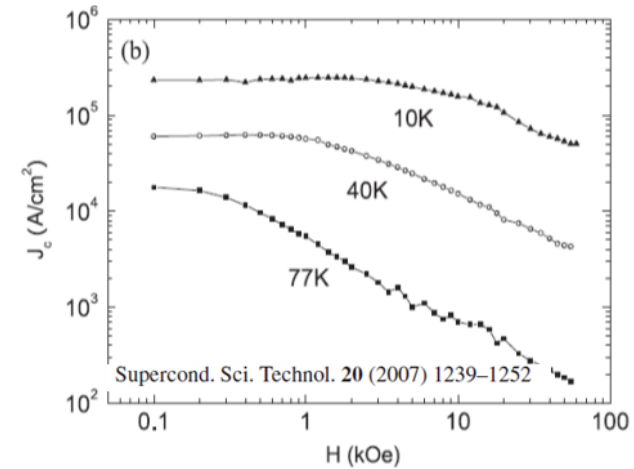
$$X_{sf} \equiv X_f = R_n \sqrt{2} \sqrt{\frac{B_0}{B_{c2}}} \left(\frac{\nu}{\nu_0} \right)^{1/2} \quad \text{for } \nu \ll \nu_0.$$

Assuming:
(conservative estimate)

$$\rho_n = 40 \mu\Omega \text{ cm}$$

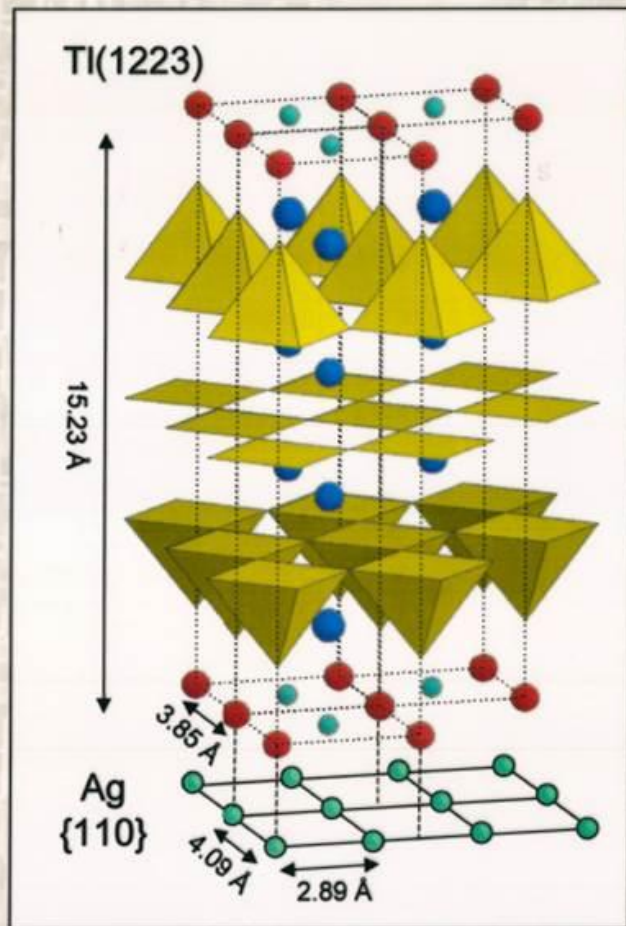
$$B_{c2} (50K) = 70T.$$

$$J_c \div 10^8 \text{ to } 10^9 \text{ A/m}^2$$



At low frequencies, where the most unstable modes are predicted for a copper beam screen, a substantial gain of several orders of magnitude is clearly apparent

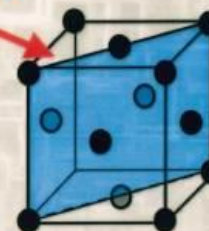
Electrodeposition



Lattice parameter matching of Ti(1223) and silver

The Ag{110} :

{110} plane



Initial Ag

Cold Rolling
20% reduction at each pass

Bridgman technique

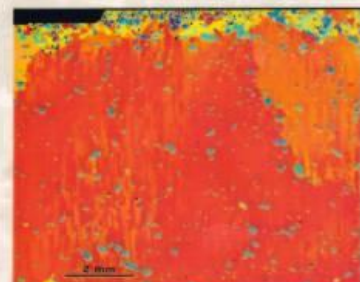
Recrystallization
Vacuum 800 °C

Orienting by X-ray
Laue method

{110} textured ribbons

cutting
(electroerosion)
polishing and
chemical etching

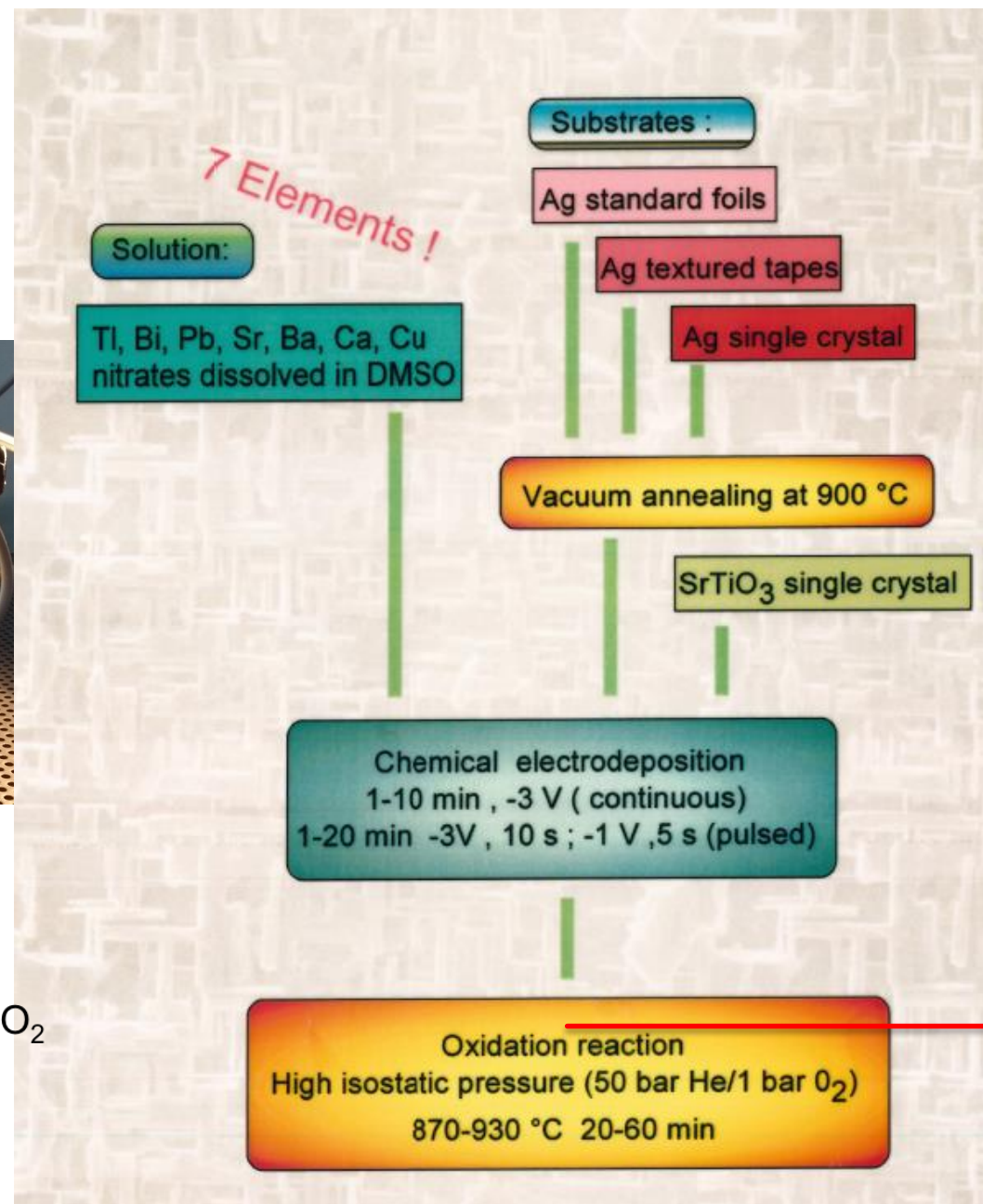
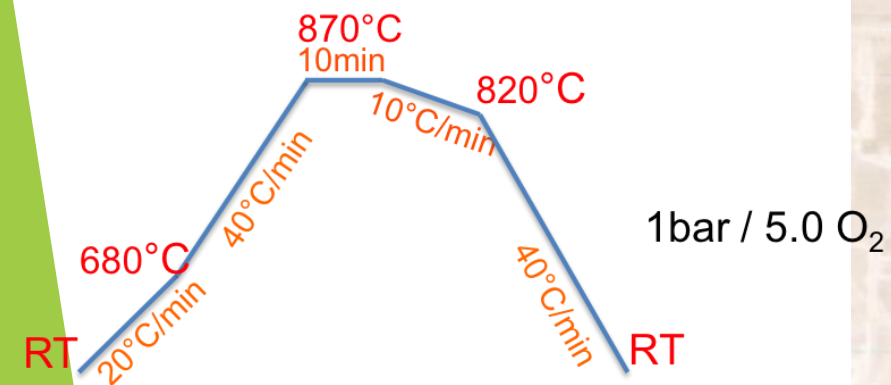
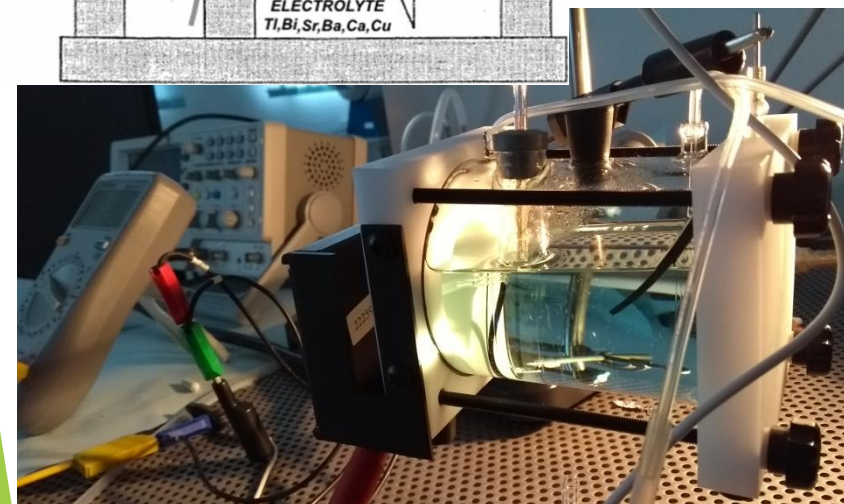
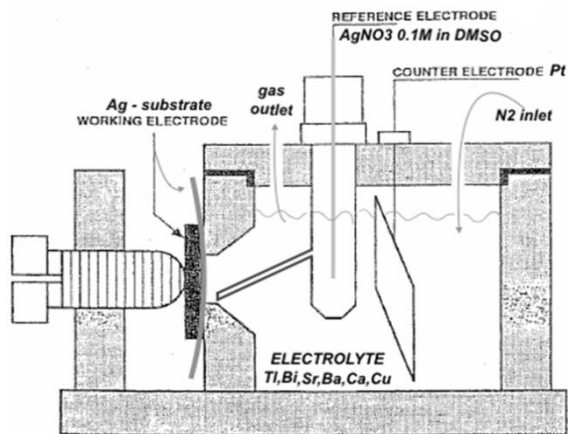
{110} Single crystal



0 5 10°

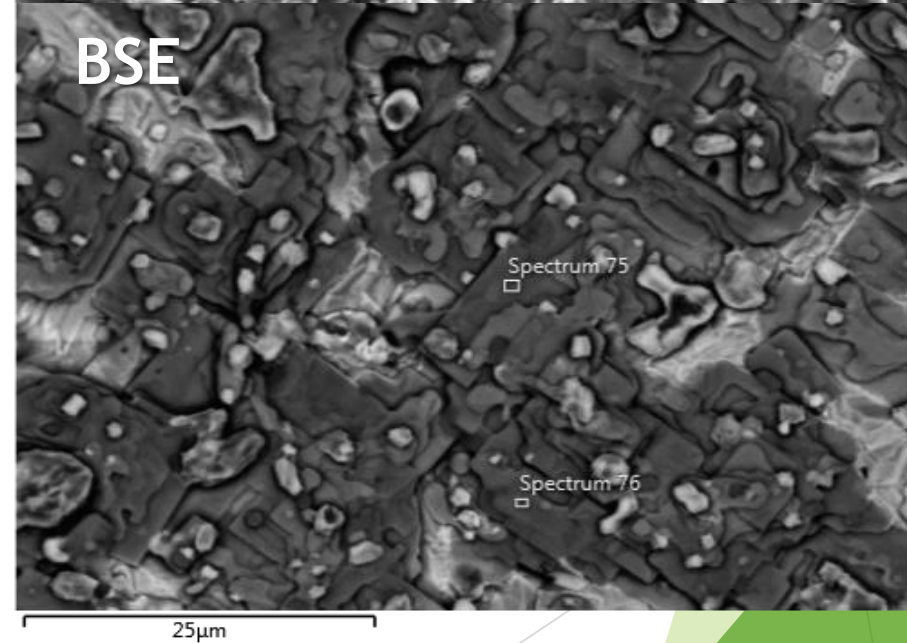
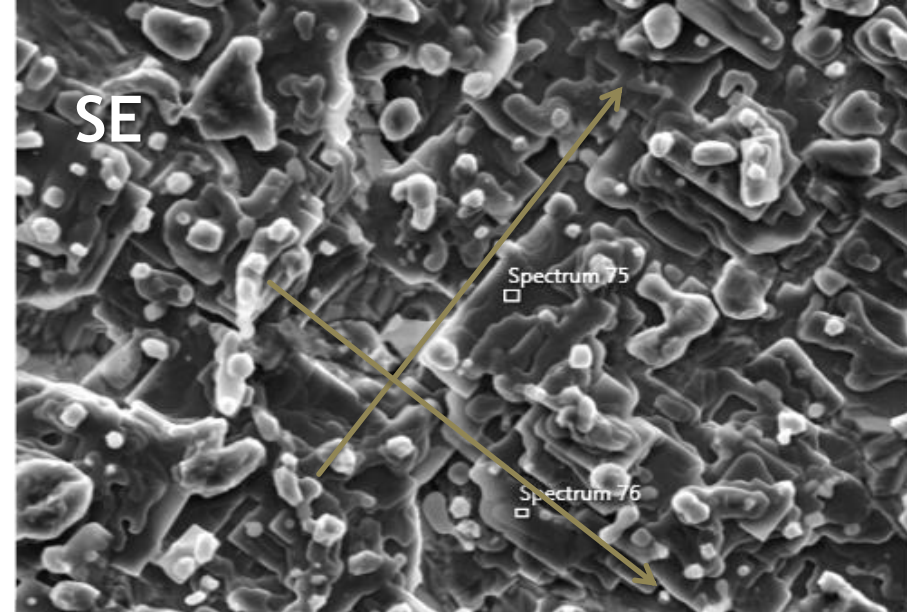
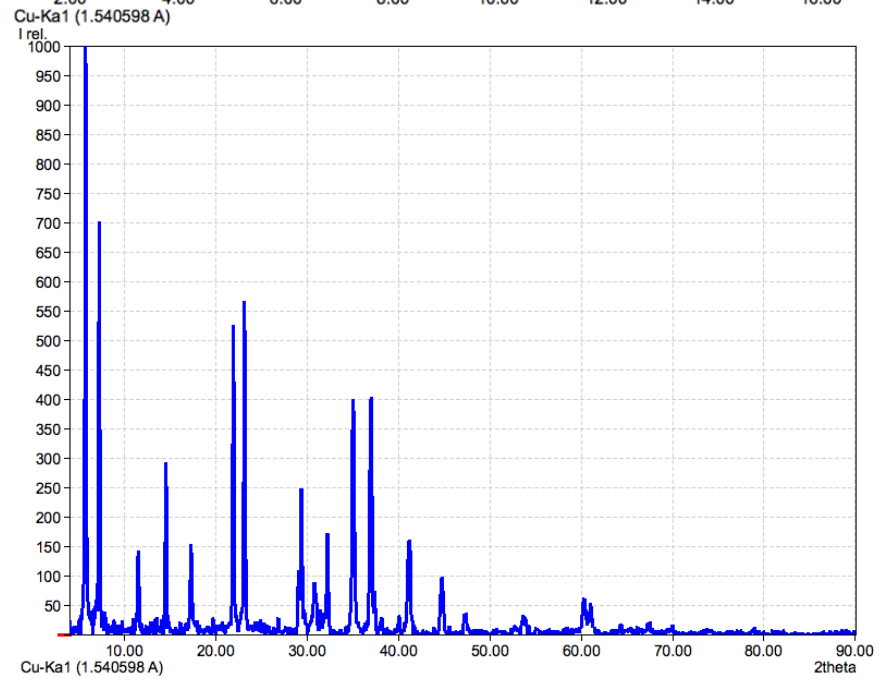
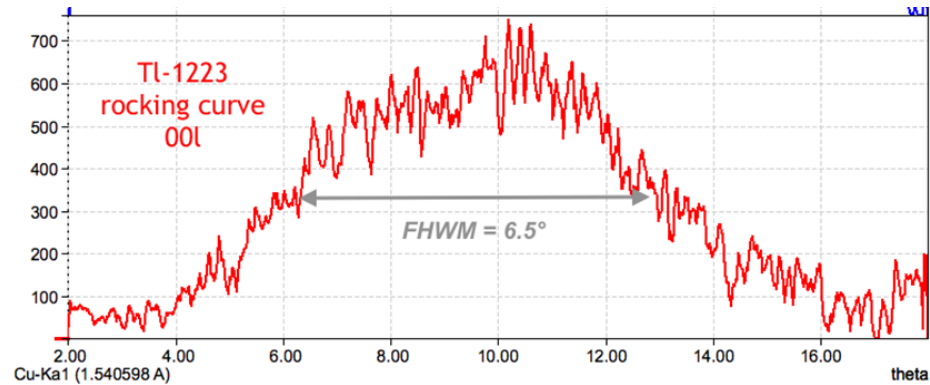
Electron Back Scattered Diffraction map (EBSD)

The misorientation angle is less than 4° (normal direction)



As rolled Ag ribbon

c axis texture
on Ag grain local epitaxy



Thank you for your attention